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M PTO-1449/A and B (Modified)		APPLICATION NO.: 10/075,092	ATTY. DOCKET NO.: S01022.80748.US
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		FILING DATE: February 12, 2002	CONFIRMATION NO.: 7263
		APPLICANT: Roy Francois	
		GROUP ART UNIT: 281/5	EXAMINER: Allan R. Wilson
Sheet	1	FEB 04 2003	2

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EXAMINER <i>A. R. Wilson</i>	DATE CONSIDERED <i>5/1/03</i>
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#EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.